

Substitute for form 1449/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (Use as many sheets as necessary)				<b>Complete if Known</b>	
				Application Number	10/817,620
				Filing Date	April 1, 2004
				First Named Inventor	Carl Woods
				Art Unit	1746
				Examiner Name	Unassigned
Sheet	2	of	4	Attorney Docket Number	LAM2P487

## U.S. Patent Documents

Examiner Initials	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
VB 4/15/08 /JLP/	A	2005/0148197	<del>04/01/04</del>	Woods et al.	07/2005
	B	2005/0217703	10/06/05	O'Donnell	
	C	2006/0064895	03/30/06	Garcia et al.	
	D	3,953,265	04/27/76	Hood	
	E	4,367,123	01/04/83	Beck	
	F	4,444,492	04/24/84	Lee	
	G	5,102,494	04/07/92	Harvey et al.	
	H	5,180,431	01/19/93	Sugimoto et al.	
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	L	5,472,502	12/05/95	Batchelder	
	M	5,558,111	09/24/96	Lofaro	

## Foreign Patent Documents

Examiner Initial	Cite No. <sup>1</sup>	Foreign Patent Document No.	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number-Kind Code <sup>5</sup> (if known)				
/JLP/	N	JP11031672 (Patent Abstract in English provided)	02/02/99	Hitachi Ltd.		
/JLP/	O	WO 03/014416 A2	02/20/03	Ebara Corporation		<input type="checkbox"/>

## Non Patent Literature Documents

Examiner Initial	Cite No.	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
/JLP/	P	ICKnowledge LLC, "Technology Backgrounder: Atomic Layer Deposition", ICKnowledge.com, 2004, Pages 1-7
/JLP/	Q	"Chemical vapor deposition", Wikipedia, the free encyclopedia, <a href="http://en.wikipedia.org/wiki/Chemical_vapor_deposition">http://en.wikipedia.org/wiki/Chemical_vapor_deposition</a> , 2005, Page 1-2

Examiner Signature	/Joseph L. Perrin/	Date Considered	06/25/2007
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Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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